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By Sandy Kim  
Sandy Kim

PATENT  
Attorney Docket No.: AM524R1/T289

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent of:

MUSAKA et al.

Serial No.: 09/187,551

Date: November 5, 1998

For: METHOD OF FORMING A THIN  
FILM FOR A SEMICONDUCTOR  
DEVICE

Examiner: Unassigned

Art Unit: 1762

CHANGE OF CORRESPONDENCE  
ADDRESS

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Sir:

Please change the correspondence address for this application as follows:

Patent Counsel, M/S 2061

Legal Affairs Department

Applied Materials, Inc.

P.O. Box 450A

Santa Clara, CA 95052

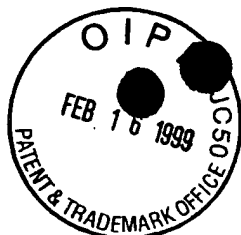
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FEB 18 1999  
GROUP 1700

Respectfully submitted,

Scott W. Hewett  
Reg. No. 41,836

TOWNSEND and TOWNSEND and CREW LLP  
(650) 326-2400  
Fax (650) 326-2422  
SWH:sgk  
PA 175374 v1

FILING RECEIPT



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APPLICATION NUMBER	FILING DATE	GRP ART UNIT	FIL FEE REC'D	ATTORNEY DOCKET NO.	DRWGS	TOT CL	IND CL
09/187,551	11/05/98	1762	\$1,168.00	AM524R1/T289	9	26	5

~~TOWNSEND AND TOWNSEND AND CREW~~  
~~379 LYTTON AVE~~  
~~PALO ALTO CA 94301~~

PATENT COUNSEL, M/S 2061  
LEGAL AFFAIRS DEPARTMENT  
APPLIED MATERIALS, INC  
P.O. Box 450A  
SANTA CLARA, CA 95052

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Applicant(s)

KATSUYUKI MUSAKA, INBA, JAPAN; SHINSUKE MIZUNO, INBA,  
JAPAN.

CONTINUING DATA AS CLAIMED BY APPLICANT-

THIS APPLN IS A RE OF 08/259,584 06/14/94 PAT 5,571,571  
WHICH IS A CIP OF 08/184,331 01/19/94 ABN

FOREIGN APPLICATIONS- JAPAN 3-145070 06/16/93

TITLE

METHOD OF FORMING A THIN FILM FOR A SEMICONDUCTOR DEVICE

PRELIMINARY CLASS: 427

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DATA ENTRY BY: BATES, DIANE

TEAM: 03 DATE: 02/01/99

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